



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Kenji HOSHI et al.**

Art Unit: **2891**

Application Number: **10/073,314**

Examiner: **Amar Movva**

Filed: **February 13, 2002**

Confirmation Number: **4466**

For: **SEMICONDUCTOR DEVICE AND ALIGNMENT SENSING METHOD FOR  
SEMICONDUCTOR DEVICE**

Attorney Docket Number: **020171**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.114**

**MAIL STOP: RCE**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 8, 2008

Sir:

This paper is filed in response to the Final Office Action dated April 10, 2008. The response date having been extended by one month to August 10, 2008 by the Petition for Extension of Time filed herewith.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.